

02/14/03

Docket No. 212/361

1765
#5
02/25/03

IN THE UNITED STATES PATENT & TRADEMARK OFFICE

In re Application of:

Kassir, Salman M.

Serial No.: 10/059,701

Filed: January 29, 2002

For: Method of Spin Etching
Wafers With an Alkali
Solution

Art Unit: 2812

Examiner: unassigned

Substitute Drawings

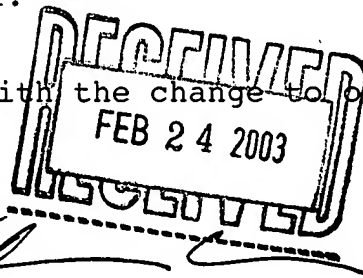
Assistant Commissioner For Patents
Office of Initial Patent Examination
Customer Service Center
Washington, D.C. 20231

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Sir:

Enclosed please find the following [4] sheets of drawings
for U.S. Patent Application No. 10/059,701.

Please charge any fee associated with the change to our
deposit account 03-3700.



Date: February 12, 2003

By:

K. David Crockett, Esq.
Reg. No. 34,311

Certificate of Mailing (37 CFR 1.10)

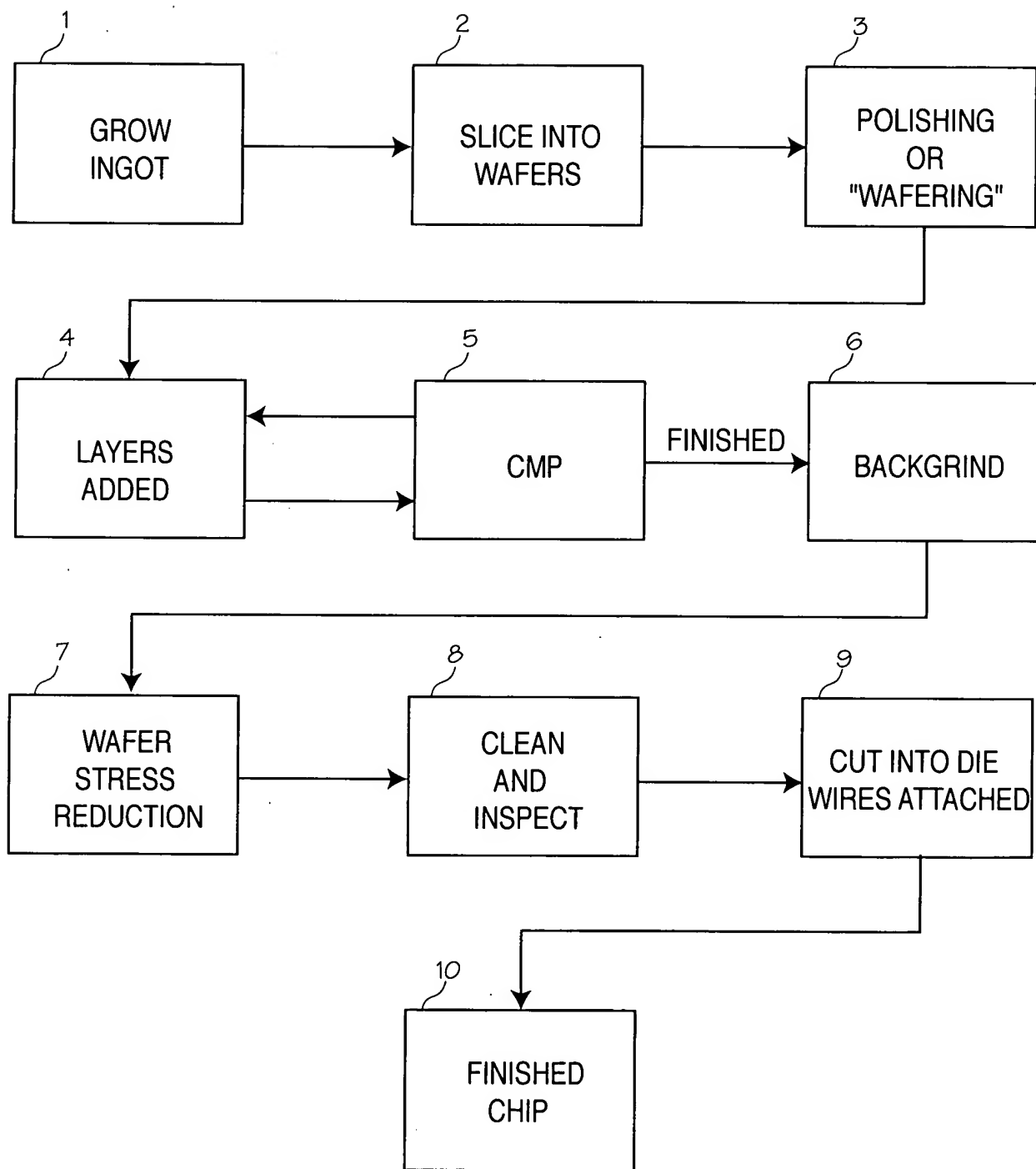
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Fig. 1



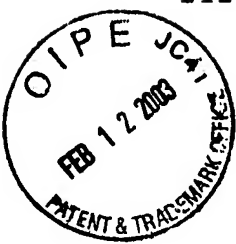


Fig. 2

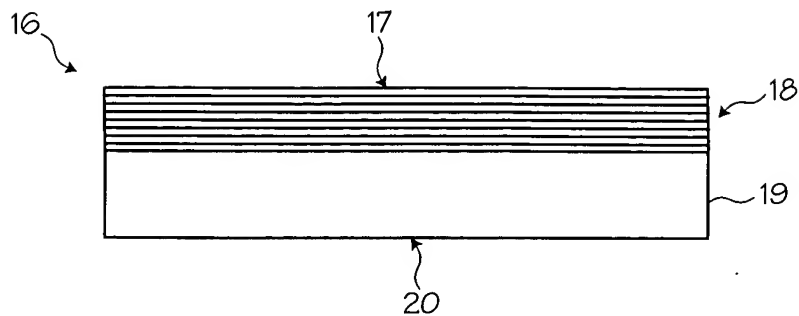


Fig. 3

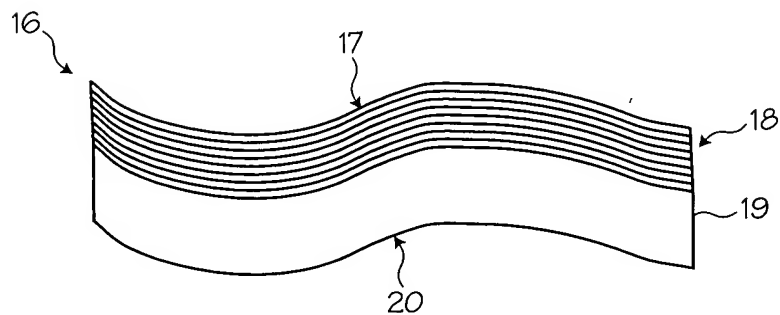


Fig. 4a

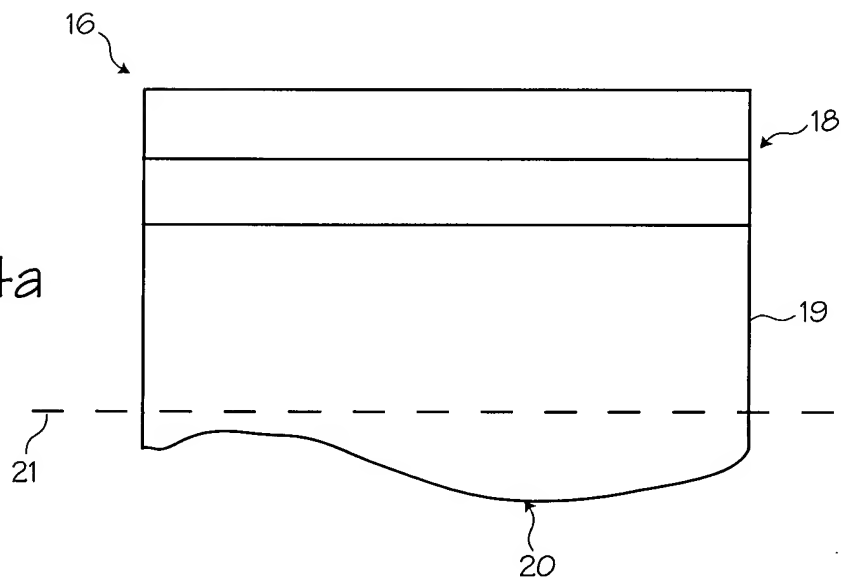
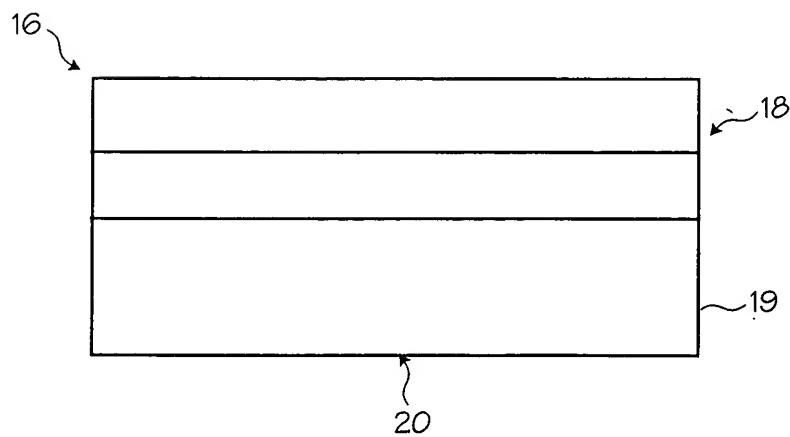


Fig. 4b



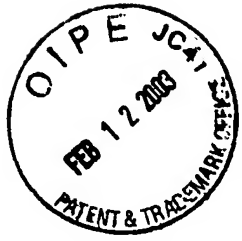


Fig. 5

3/4

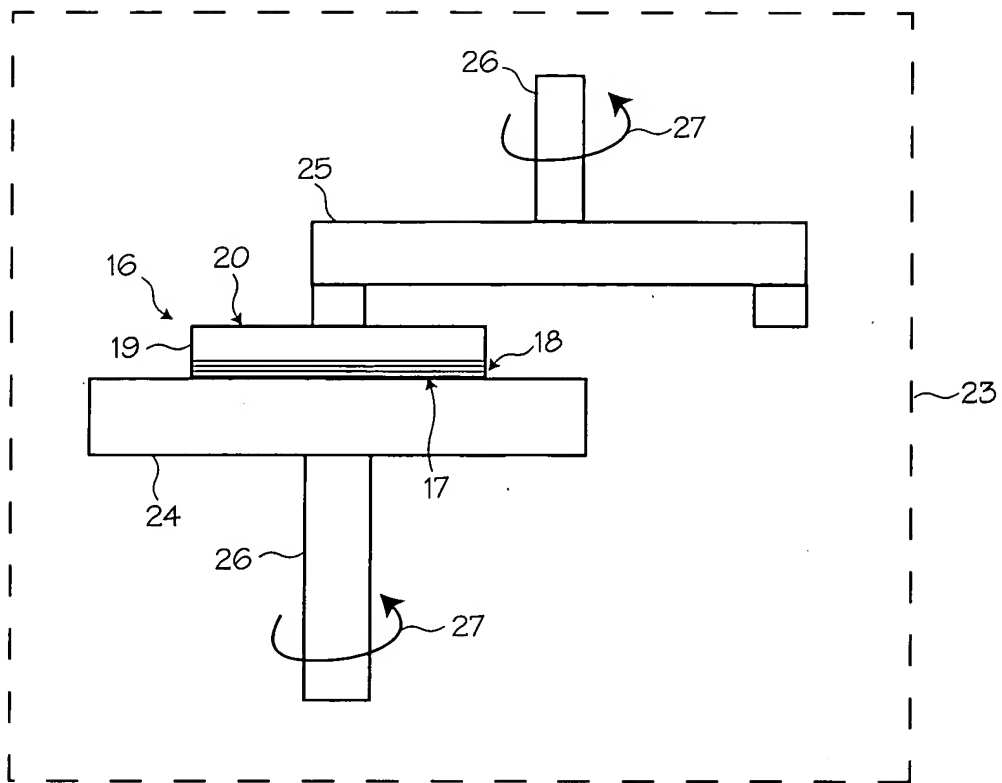
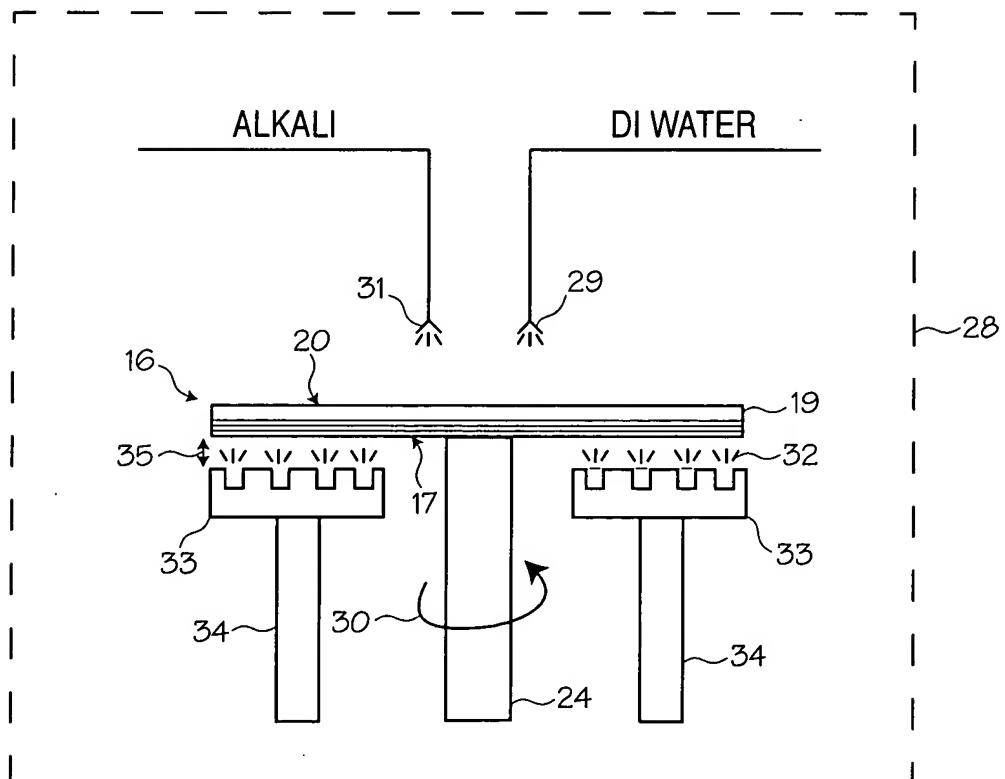


Fig. 6



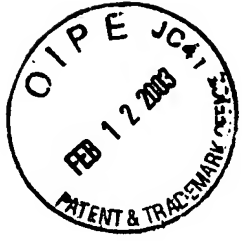


Fig. 7

